



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

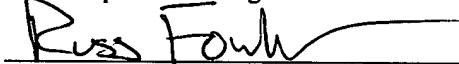
In re Application of: Tilke et al. ) Group Art Unit: 2811  
 )  
 Attorney Docket No. 1890-0061 ) Confirmation No.: 7063  
 )  
 Application No.: 10/780,276 ) Examiner: Thien F. Tran  
 )  
 Filed: February 17, 2004 )  
 )  
 For: Semiconductor Structure With )  
 Increased Breakdown Voltage and )  
 Method for Producing the )  
 Semiconductor Structure )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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AMENDMENT & RESPONSE

Sir:

In response to the Office action of May 3, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.